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1763

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor : Tatsuya SUZUKI

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Pursuant to 37 C.F.R. 1.10.

by *J. Davis D.*
Patricia L. Blum

Serial No. : 09/823,058

Filed : March 30, 2001

Title **STOCK/TRANSFER VESSEL FOR
SEMICONDUCTOR SUBSTRATE AND METHOD
OF MANUFACTURING SEMICONDUCTOR
DEVICE**

Examiner : Karla A. Moore

Group Art Unit : 1763

#10BNR
#1103
m/w)

March 26, 2003

Commissioner for Patents
Washington, D.C. 20231

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C 1763 MAIL ROOM

Sir:

In response to the Office Action dated December 26, 2002, please amend the subject application as follows:

IN THE CLAIMS

Please cancel claims 3 and 13 without prejudice or disclaimer.

Please amend claims 1 and 10 as follows:

1. (Amended) A semiconductor substrate stock/transfer vessel, which is an openable/closeable sealed vessel used in a semiconductor device manufacturing process and adapted to store or transfer a semiconductor substrate,